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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Hyung Jun Kim	)	I hereby certify that this paper is being deposited with the United States Postal Service as first class mail, postage prepaid, in an envelope addressed to: Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on this date:
Serial No. 10/616,198	)	
Filed: July 9, 2003	)	
For: Method of Detecting a Polishing End Point in a Chemical Mechanical Polishing Process	)	June 30, 2005
Group Art Unit: 1765	)	*Andrew M. Lawrence* (signature)
Examiner: Lynette T. Umez-Eronini	)	Andrew M. Lawrence, Reg. No. 46,130 Attorney for Applicant

INFORMATION DISCLOSURE STATEMENT

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Submitted herewith for consideration by the examiner is a copy of the document identified on the attached Form PTO-1449.

The item of information contained in this information disclosure statement was first cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing (*i.e.,* mailing) of this information disclosure statement. In accordance with 37 CFR §§1.97(c)(1) and (e)(1), no fee is due.

An early and favorable action on the merits is respectfully requested.

Respectfully submitted,

MARSHALL, GERSTEIN & BORUN LLP

Andrew M. Lawrence (signature)

June 30, 2005

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Form PTO-1449 (Modified)	Atty. Docket No. 29936/39457	Serial No. 10/616,198
INFORMATION DISCLOSURE STATEMENT	Applicant(s) Hyung J. Kim	
	Filing Date July 9, 2003	Art Unit 1765

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U.S. PATENT DOCUMENTS

Examiner Initials	Document Number	Issue or Publication Date	Name	Class	Subclass	Filing Date (If Appropriate)

FOREIGN PATENT DOCUMENTS

Examiner Initials	Document Number	Publication Date	Country	Translation Yes	No
	2000-260736	09/22/2000	JP	Abstract only	

OTHER DOCUMENTS

EXAMINER:	DATE CONSIDERED: